



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

VA 22313-1450.

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Patent Application

Applicant(s): J.M. Brennan et al.

Case:

2-81-1-4

Serial No.:

10/773,614

Filing Date:

February 6, 2004

Group:

2823

Examiner:

Brook Kebede

Title:

Semiconductor Device Configured for

Reducing Post Fabrication Damage

TRANSMITTAL LETTER

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith is the following document relating to the above-identified patent application:

(1) Response to Non-Final Office Action.

There is no additional fee due in conjunction with the response. In the event of any non-payment or improper payment of a required fee, the Commissioner is hereby authorized to charge or to credit Ryan, Mason & Lewis, LLP Deposit Account No. 50-0762 as required to correct the error.

Respectfully submitted,

Date: August 18, 2006

Wayne L. Ellenbogen Attorney for Applicant(s)

Reg. No. 43,602

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Date: August 18, 2006

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RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the outstanding Office Action dated May 22, 2006, Applicants submit herewith the following remarks: